

<b>Notice of References Cited</b>	Application/Control No. 10/016,099	Applicant(s)/Patent Under Reexamination AGRAWAL ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0204850 A1	10-2004	MacNeille et al.	701/213
	B	US-2003/0108017 A1	06-2003	Famolari, David	370/338
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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